## **ITG** WORKSHOP: Vacuum Electronics 2024

#### organized by ITG-Fachausschuss MN 6 "Vacuum Electronics and Displays"



ITG Information Technology Society within VDE

August 28 - 30, 2024 in Bad Honnef, Germany

# Call for Papers

### The 9<sup>th</sup> ITG International Vacuum Electronics Workshop (IVEW) 2024

### August 28 - 30, 2024 Physikzentrum, Bad Honnef, Germany

(www.pbh.de)

#### **Topics of the Conference**

New developments and applications of vacuum electronic devices as well as materials, technologies and manufacturing techniques such as:

- Vacuum Electronic and Discharge Devices and their Applications
- Technologies and Production Processes in Vacuum Electronics

#### SCHEDULE

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Deadline for Submission of Abstracts	May 6, 2024
Notification of Acceptance	June 10, 2024
Deadline for Registration and Payment	July 19, 2024
Submission of Presentations in .pdf format	•
for the Electronic Proceedings	August 29, 2024

Files (**abstracts and presentations**) shall be sent electronically. See abstract template (**sample paper abstract**) on Web Site.

The latest information on the conference and the final program can be found at the Web Site <a href="http://www.ihm.kit.edu/VDE-ITG\_FA\_MN6.php">http://www.ihm.kit.edu/VDE-ITG\_FA\_MN6.php</a>

#### Submitted papers should include but are not limited to the following areas of interest:

#### Vacuum Electronic and Discharge Devices and their Applications

- Microwave Tubes
- Grid Controlled Tubes
- Vacuum Microelectronic and Nanoelectronic Devices
- Picture Tubes and Image Intensifiers
- X-Ray Tubes
- Vacuum Interrupters and Spark Gaps
- Pseudospark Devices
- Vacuum Arc Ion Sources
- High Current Diodes
- Pulsed Power Switching
- Gas Lasers and Gas Discharge Tubes
- Electric Space Propulsion

#### **Technologies and Production Processes in Vacuum Electronics**

- Laser-, Electron-Beam-, Ion-Beam- and Plasma Processing Systems
- Surface Treatment, Evacuation and Getters
- Interconnection and Assembly Techniques
- Vacuum-Microelectronics and Vacuum-Nanoelectronics Technologies
- Electron Sources and Electron Emission

The paper should be suitable for **20 minutes of oral presentation.** Poster presentations are welcome. The conference language is English.

**One-page abstracts** should be submitted as .pdf-file electronically to the Conference Chairmen **not later than May 6, 2024.** Please indicate if you prefer a poster presentation.

Conference Chairman:	Vice Chairman:
DrIng. Wolfram Knapp	Prof. Dr. Dr. h.c. mult. Manfred Thumm
Knapptron GmbH	Karlsruher Institut für Technologie (KIT)
Vakuumelektronik	Institut für Hochleistungsimpuls- und
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The Program Committee will decide on the selection of papers and posters and will notify the authors by **June 10, 2022**. In case of acceptance, the authors are requested to prepare their contributions in .pdf format for publication in the electronic proceedings. Files shall be handed over at the workshop in Bad Honnef by August 29, 2024.